PATENT APPLICATION

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in re the Application of

Vidya VENKATACHALAM

Group Art Unit: 2613

Application No.: 10/632,823

Examiner:

Unknown

Filed: August 4, 2003

Docket No.: 115975

For:

METHODS AND APPARATUS FOR INSPECTION OF LINES EMBEDDED IN HIGHLY

TEXTURED MATERIAL

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- \boxtimes This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- \boxtimes The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,

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Date: January 4, 2006

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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DO	OCKET NO.	APPLICATION NO. 10/632,823				
INFORMATION DISCLOSURE STATEMENT										
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	2	Doudkin et al., "Contour Extraction Algorithms for LSI Circuit Video Image Processing," Proceedings of the International Workshop on Intelligent Data Acquisition and Advanced Computing Systems: Technology and Applications, pp. 69-72, July 2001.								
	3	Allada et al., "Efficient Vertex Detection Algorithms Using the Hough Transform," <u>International Journal of Advanced Manufacturing Technology</u> , Vol. 11, No. 6, pp. 394-405, 1996.								
										
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